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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant(s): **Chen et al.**

Case: **1717 P2**

Serial No.: **09/512,734**

Filed: **February 18, 2000**

Title: **METHOD AND APPARATUS FOR ANNEALING COPPER FILMS**

THE COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D. C. 20231

S I R:

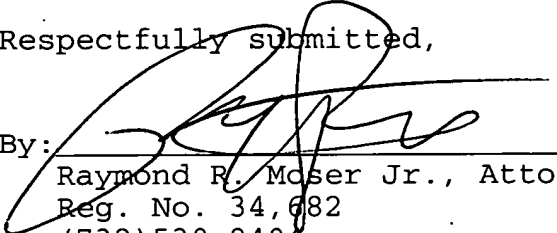
Disclosure Statement under 37 CFR 1.56 and 1.98

Pursuant to 37 CFR 1.56, the documents (copy enclosed) listed on form PTO-1449, submitted herewith, is disclosed. The applicants believe that the subject matter disclosed in the enclosed conference abstract is related to the above-referenced application. The applicants believe that the conference was held during October 17-22, 1999, but are not aware of the abstract being published prior to the conference date.

The applicants believe that no fee is due, but in the event that a fee is due, kindly charge that fee to deposit account number 20-0782.

Respectfully submitted,

6-20-00
Date

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CERTIFICATE OF MAILING under 37 C.F.R. 1.8(a)

I hereby certify that this correspondence is being deposited on June 22, 2000 with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Michael Civel
Signature

6-22-00
Date of signature